

Technology Center 2100

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

<div>LIST OF PRIOR ART CITED BY APPLICANT</div> <div>(PTO-1449)</div> <div><div>OTPM</div><div>JUL 08 2003</div><div>PATENT & TRADEMARK OFFICE</div></div>				ATTY. DOCKET NO. CIT/K-108		APPLN. SERIAL NO. 09/495,250	
				APPLICANT(S) Jin Soo LEE and Hyeon Jun KIM			
				FILING DATE January 31, 2000		GROUP 2172	
U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE	
U.S. PATENT APPLICATION PUBLICATIONS							
	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS		
U.S. PATENT APPLICATIONS							
	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS		
FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
h	08-313615	06/09/1998	Japan			Abst.	
h	07-260148	04/15/1997	Japan			Abst.	
U	07-055937	09/27/1996	Japan			Abst.	
h	07-055935	09/27/1996	Japan			Abst.	
U	06-028059	09/12/1995	Japan			Abst.	
OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)							
EXAMINER				DATE CONSIDERED	Technology Center 2100		

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